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Date : January 12, 2005

TO : Director, Office of Patent Publication

FROM : Office of the Deputy Commissioner
for Patent Examination Policy

SUBJECT : Withdrawal from Issue of **Application No. 10/026,802**

Applicant(s) : Hisashi Ohtani et al
Application No. : 10/026,802
Filed : December 27, 2001

The above-identified application has been assigned Patent No. 6,847,049 and an issue date of January 25, 2005.

It is hereby directed that this application be withdrawn from issue at the request of the applicant. Do not refund the issue fee.

The following erratum should be published in the Official Gazette if the above-identified application is published in the OG of January 25, 2005:

"All reference to Patent No. 6,847,049 to Hisashi Ohtani et al of Japan for METHOD FOR MANUFACTURING A SEMICONDUCTOR DEVICE appearing in the Official Gazette of January 25, 2005 should be deleted since no patent was granted."

Frances Hicks
Petitions Examiner
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for Patent Examination Policy

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